

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Ikeuchi, Katsushi et al.	) Group Art Unit: 2624
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Application No.: 10/598,010	) Examiner: Werner, Brian
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Filed: May 2, 2007	)
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For: Shape Measurement Device and	)
Method Thereof	)
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**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Attached hereto is a PTO/SB/08a form listing a document cited in an Office Action dated February 20, 2009 which was issued in connection with the Canadian patent application corresponding to the present application, Canadian Patent Application No. 2,555,773. In the Office Action, this document (Japanese Patent No. 11238136) was cited in connection with a rejection of claims 1 and 9 of the Canadian patent application on the ground that these claims do not comply with Section 28.3 of the Canadian Patent Act, i.e., that the subject matter of these claims would have been obvious to a person skilled in the art to which they pertain having regard to Japanese Patent No. 11238136 in view of general knowledge in the art.

It is believed that this disclosure complies with the requirements of 37 CFR § 1.56 and the Manual of Patent Examining Procedures Section 707.05 (b). If the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

No fee is believed due in connection with this communication. However, if it is determined that a fee is due, the Commissioner is hereby authorized to charge payment of any fees to Deposit Account Number 19-2090.

Respectfully submitted,

SHELDON MAK ROSE & ANDERSON

Date: June 25, 2009

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